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	Application No.	Applicant(s)		
Notice of Allowability	10/665,112 Examiner	NAGAI ET AL. Art Unit	NAGAI ET AL.	
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	Tai Van Nguyen	3729		
The MAILING DATE of this communication apperatus being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED or other appropriate comm IGHTS. This application is	in this application. If not inclu- nunication will be mailed in du	ded e course. THIS	
1. 🖂 This communication is responsive to <u>8 April 2005 and 27 I</u>	<i>May 2005</i> .			
2. The allowed claim(s) is/are <u>1-7</u> .				
3. The drawings filed on 22 September 2003 are accepted by	the Examiner.			
 4. Acknowledgment is made of a claim for foreign priority unally all b) Some* c) None of the: Certified copies of the priority documents have Certified copies of the priority documents have Copies of the certified copies of the priority documents have Copies of the certified copies of the priority do International Bureau (PCT Rule 17.2(a)). * Certified copies not received: Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 	e been received. e been received in Applicat cuments have been receive of this communication to fi	ion No. <u>09/508,168</u> ed in this national stage applic		
A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv			NOTICE OF	
6. CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner Paper No./Mail Date	st be submitted. son's Patent Drawing Revie s Amendment / Comment o	ew (PTO-948) attached or in the Office action of		
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the	l.84(c)) should be written on the header according to 37 C	the drawings in the front (not t FR 1.121(d).	he back) of	
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MAT FOR THE DEPOSIT OF B	FERIAL must be submitted. IOLOGICAL MATERIAL.	Note the	
Attachment(s) 1. Notice of References Cited (PTO-892)	5. ☐ Notice of	nformal Patent Application (P	TO-152)	
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. X Interview	Summary (PTO-413),	-	
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/		o./Mail Date s Amendment/Comment		

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of Biological Material

8. X Examiner's Statement of Reasons for Allowance

9. Other ____.

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Michael Britton on 27 May 2005.

The application has been amended as follows:

In the claim:

Non-elected claims 8-14 have been cancelled.

Reasons for allowance:

The following is an examiner's statement of reasons for allowance: the prior art does not teach all limitations of the claimed invention including:

- forming a first mask covering regions corresponding
 to portions of the conduction electrodes, and having
 apertures in the conduction electrode forming regions
 excluding the portions and in the exciting electrode
 forming regions;
- removing the first noble metal layers exposed from
 the apertures, each of the electrode patterns in the
 exciting electrodes comprising the under metal layer,
 each of the electrode patterns in the conduction

electrodes comprising the under metal laver and each of the electrode patterns in the portions comprising the under metal laver and the noble metal layer;

Accordingly, claims 1-7 are allowed.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Tai Van Nguyen whose telephone number is 571-272-4567. The examiner can normally be reached on M-F (7:30 A.M - 4:30 P.M).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Peter Vo can be reached on 571-272-4690. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

TN.

May 26, 2005

A. DEXTER TUGBANE

5/27/05